



Docket No.: 071971-0432

PATENT**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Satoshi SHIBATA

**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE**

Application No.: 10/557,746

Customer No.: 53080

Filed: November 21, 2005

Confirmation No.: 2300

Group Art Unit: 2813

Examiner: Crawford, Latanya N

Title: MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE

AMENDMENT UNDER 37 CFR 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated November 28, 2007, having a three-month shortened statutory period for response set to expire February 28, 2008, please amend the above-identified application as follows.